



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of

William S. Kennedy et al.

Application No.: 10/623,540

Filed: July 22, 2003

For: ELECTRODE ASSEMBLY FOR PLASMA
PROCESSING APPARATUS

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)
) Group Art Unit: 1763
)
) Examiner: R. Zervigon
)
) Confirmation No.: 4866
)
)
)

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

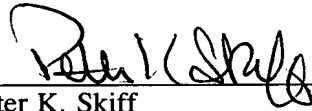
In response to the restriction requirement set forth in the Official Action dated May 2, 2005, Applicants hereby elect, with traverse, the invention covered by Group I, Claims 1-21.

Early and favorable consideration on the merits is respectfully requested.

Respectfully submitted,

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Date May 11, 2005
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